



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re U.S. Patent Application

Applicant:

Shigeru Okamoto

Serial No.:

09/521,389

Filed:

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For:

EMBEDDED ELECTRO-

CONDUCTIVE LAYER AND METHOD FOR FORMATION THEREOF

Art Unit:

2823

Examiner:

Eaton, K.

I hereby certify that this paper is being deposited with the United States Postal Service as FIRST-CLASS mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on this date.

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Appr. February 20, 1998

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Sir:

Please direct all future correspondence concerning the above-identified application to

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Respectfully submitted,

GREER, BURNS & CRAIN, LTD.

August 7, 2001

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